### **International Prosecution**

-Tips on how to prepare a global filing with considerations for China

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# **Agenda**

- China patent system
- Tips for preparation considering a Chinese filing
  - **≻**Specifications
  - **≻Claims**

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#### **China Patent System**

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## **China Patent System**

- First-to-file system
- Three types of patents
  - >Invention patents
  - >Utility model patents
  - **≻**Design patents
- Three ways of filing
  - **➢ Direct filing**
  - **▶** Paris convention filing
  - > PCT filing with China as designated country

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## **China Patent System - Invention**

- Eligible subject matter
  - **≻**Technical requirements (problem means effects)
  - >Statutory exceptions
- Novelty
- Inventiveness (three-step method)
  - > Determining the closest prior art
  - > Determining the distinguishing tech features of the invention v. tech problem actually solved by the invention
  - ➤ Determining whether the claimed invention is obvious to a PSITA
- Usefulness

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**Drafting Tips** 

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